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CONFIRMATION NO. 1088

Bib Data Sheet

SERIAL NUMBER 10/656,239	FILING DATE 09/08/2003  RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. 0756-7198
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## APPLICANTS

Hisashi Ohtani, Atsugi-shi, JAPAN;

Tamae Takano, Atsugi-shi, JAPAN;  
Chiho Kokubo, Atsugi-shi, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 10/214,693 08/09/2002 ABN  
 which is a DIV of 09/120,244 07/22/1998 PAT 6,432,756

*US*  
*DL*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 9-216002 07/24/1997  
 JAPAN 10-151543 06/01/1998

*US*  
*DL*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 12/12/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 32	INDEPENDENT CLAIMS 6
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	Met after Allowance <input type="checkbox"/> yes <input checked="" type="checkbox"/> no			
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>				

## ADDRESS

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 ERIC ROBINSON  
 PMB 955  
 21010 SOUTHBANK ST.  
 POTOMAC FALLS, VA  
 20165

## TITLE

*Method of manufacturing*

Semiconductor device and fabricating method thereof

FILING FEE  RECEIVED 1218	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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## \*BIBDATASHEET\*

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